

<b>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</b>					Attorney's Firm Number: 9D-DW-19776		
Applicant: Hegeman et al		Serial Number: 09/742,548		Filing Date: 12/22/00		Group Art Unit: 1746	
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date	Name	Class	Sub-Class	Filing Date	
JP	AA	6,103,017	Aug. 15, 2000	Thies et al.	134	10	3/19/99
	AB	5,909,743	Jun. 8, 1999	Thies et al.	134	10	9/10/97
	AC	5,848,601	Dec. 15, 1998	Thies	134	104.4	10/10/97
	AD	5,803,100	Sep. 8, 1998	Thies	134	104.4	8/8/96
	AE	5,779,812	Jul. 14, 98	Thies et al.	134	10	8/8/96
	AF	5,711,326	Jan. 27, 98	Thies et al.	134	104.4	8/8/96
	AG	5,730,805	Mar. 24, 98	Bertsch et al.	134	10	8/8/96
FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Sub-Class	Translation	
JP	AH	EP 0 842 632 A2	May 20, 98	European	—	—	11/17/97
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, etc.)							
Examiner Initial	DESCRIPTION						
EXAMINER: JP R				DATE CONSIDERED: 01/22/03			

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.


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#IDS

# Electronic Information Disclosure Statement



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OCT 25 2002  
TC 170

## DISHWASHER PRESSURIZED FINE FILTER DRAIN APPARATUS AND METHOD

Application:   
09/742544

Confirmation: 6864

Applicant(s): Arjan Hegeman

Docket Number: 9D-DW-19418













Group Art Unit: 1746

Examiner: PERRIN

search string: (4150679 or 4848382 or 5165433 or 5345957 or 5377707 or 5499640 or 5601660 or 5630437 or 5909743 ).pn.

### US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
	P01	4150679	1979-04-24		Cushing et al.	134	104.1
	P02	4848382	1989-07-18		Bertsch et al.	134	111.
	P03	5165433	1992-11-24		Meyers	134	104.4
	P04	5345957	1994-09-13		Cooper et al.	134	104.1
	P05	5377707	1995-01-03		Young, Jr.	134	104.1
	P06	5499640	1996-03-19		Kirkland	134	56D

Class/Subclass

P07	5601660	1997-02-11	Jeon et al.	134/10
P08	5630437	1997-05-20	Dries et al.	134/186
P09	5909743	1999-06-08	Thies et al.	

## Signature

Examiner Name	Date
<i>Joseph Kim</i>	01/22/03